

Electric field-controlled magnetization in bilayered magnetic films for magnetoelectric memory

Wei-Gang Yang, Nicola A. Morley, and W. Mark Rainforth

Citation: *Journal of Applied Physics* **118**, 034102 (2015); doi: 10.1063/1.4926875

View online: <http://dx.doi.org/10.1063/1.4926875>

View Table of Contents: <http://scitation.aip.org/content/aip/journal/jap/118/3?ver=pdfcov>

Published by the [AIP Publishing](#)

Articles you may be interested in

[Phase modulated magnetoelectric delta-E effect sensor for sub-nano tesla magnetic fields](#)

Appl. Phys. Lett. **107**, 152402 (2015); 10.1063/1.4932575

[Large E-field tunability of magnetic anisotropy and ferromagnetic resonance frequency of co-sputtered Fe₅₀Co₅₀-B film](#)

J. Appl. Phys. **117**, 17D702 (2015); 10.1063/1.4906752

[Amorphous FeCoSiB for exchange bias coupled and decoupled magnetoelectric multilayer systems: Real-structure and magnetic properties](#)

J. Appl. Phys. **116**, 134302 (2014); 10.1063/1.4896662

[Electric field control of magnetism in FePd/PMN-PT heterostructure for magnetoelectric memory devices](#)

J. Appl. Phys. **115**, 024903 (2014); 10.1063/1.4861618

[Direct measurements of field-induced strain at magnetoelectric interfaces by grazing incidence x-ray diffraction](#)

Appl. Phys. Lett. **102**, 011601 (2013); 10.1063/1.4773358

The logo for AIP APL Photonics is displayed. It features the letters 'AIP' in a large, white, sans-serif font on the left, followed by a vertical line and the words 'APL Photonics' in a smaller, white, sans-serif font on the right. The background is a vibrant red with a bright yellow sunburst effect emanating from the top right corner.

APL Photonics is pleased to announce
Benjamin Eggleton as its Editor-in-Chief



Electric field-controlled magnetization in bilayered magnetic films for magnetoelectric memory

Wei-Gang Yang, Nicola A. Morley, and W. Mark Rainforth^{a)}

Department of Materials Science and Engineering, University of Sheffield, Sheffield S1 3JD, United Kingdom

(Received 13 April 2015; accepted 5 July 2015; published online 15 July 2015)

Bilayered magnetic films (Co₅₀Fe₅₀ (CoFe)/Metglas) were RF sputtered on both (001)-oriented and (011)-oriented PMN-PT (lead magnesium niobate-lead titanate) substrates. Electric field-controlled magnetization changes were observed in all these samples: 65 nm CoFe/24 nm Metglas/(001) PMN-PT, 65 nm CoFe/24 nm Metglas/(011) PMN-PT, and 30 nm CoFe/12 nm Metglas/(011) PMN-PT. The maximum magnetic remanence ratio change ($\Delta M_r/M_s$) was 46% for CoFe/Metglas/(001) PMN-PT. In this heterostructure, the electric-field created two new non-volatile switchable remanence states and the as-grown remanence state was altered permanently. High-resolution transmission electron microscopy images show a sharp and smooth interface between Metglas and substrate and conversely a rougher interface was observed between Metglas and CoFe films. In the 30 nm CoFe/12 nm Metglas/(011) PMN-PT sample, a large $\Delta M_r/M_s$ of 80% along the [100] direction was measured, while the $\Delta M_r/M_s$ along the [01-1] direction was 60% at the applied electric field of 5 kV/cm, corresponding to a giant magnetoelectric coupling constant $\alpha = \mu_0 \Delta M_r/E = 2.9 \times 10^{-6}$ s/m. © 2015 AIP Publishing LLC. [<http://dx.doi.org/10.1063/1.4926875>]

INTRODUCTION

Magnetoelectric¹ random access memory (MERAM), i.e., electric field (E-field)-controlled magnetic random access memory (MRAM)² has been proposed to drastically reduce the write energy in the recording process, which is important for further miniaturization. The MERAM element^{3,4} combines bilayered ferromagnetic films (the free layer and pinned layer in a spin-valve structure) with a ferroelectric layer based on the giant magnetoresistance (GMR) effect or tunneling magnetoresistance (TMR) effect. Recently, many publications^{5–13} have studied the E-field-controlled magnetization change in the multiferroic heterostructures,^{14–16} which consist of a monolayer magnetic film and ferroelectric¹⁷ layer. However, much less studies have been done on the bilayered ferromagnetic films.

Liu *et al.*¹⁸ investigated E-field-controlled magnetization of the free layer Co in FeMn/Ni₈₀Fe₂₀/Cu/Co/PZN-PT heterostructure, where a magnetoresistance (MR) change was also demonstrated based on GMR. A minimum and maximum MR were measured when magnetic alignment of adjacent Co and NiFe layers was parallel and antiparallel, respectively. However, the magnetization and magnetic anisotropy changes vanished and the MR returned to the initial state after the E-field was removed. In other words, two different stable magnetization states at zero magnetic and electric field did not exist and therefore the device would only work if a constant E-field was applied for one of the two magnetization arrangements. This is clearly not practically useful for novel memory and logic device applications. Recently, non-volatile magnetization changes induced by the E-field have been demonstrated in monolayer magnetic films' multiferroic heterostructures, such as CoPd/PZT,¹² Ni/

PZT,¹⁹ FeGe/BiScO₃-PbTiO₃,²⁰ Ni/PMN-PT,²¹ and Co/PMN-PT.²² Wu *et al.*²¹ demonstrated the giant non-volatile magnetic remanence change ($\Delta M_r/M_s$) of 50% in Ni/(011) PMN-PT heterostructures because a large remanent strain of +1220 ppm was created when the E-field was only changed within a specific small regime (−0.14 MV/m–0.6 MV/m). Yang *et al.*²² reported the reversible and non-volatile rotation of magnetization in the Co/(001) PMN-PT heterostructures. The magnetic easy-axis (MEA) of the circular Co film rotated gradually from the direction [010] to [100] and remained stable after the E-field was removed. The experimental results were attributed to the giant strain from a phase transition from rhombohedral to monoclinic in the PMN-PT when the E-field was applied. In addition, the monoclinic phase induced by the E-field could remain stable after the E-field was removed.²²

Therefore, the next step is to demonstrate the E-field-controlled non-volatile $\Delta M_r/M_s$ in bilayered ferromagnetic films. In this study, we demonstrate a new non-volatile magnetization change in bilayered Co₅₀Fe₅₀ (CoFe)/Metglas magnetic films on (001)-oriented PMN-PT where the as-grown magnetic anisotropy is altered permanently. When an E-field from −6 kV/cm to 0 kV/cm is applied, the MEA is along the [100] direction of the PMN-PT, while when the opposite E-field from +6 kV/cm to 0 kV/cm is applied, the MEA becomes along the [010] direction of the PMN-PT. Two stable distinct magnetization states induced by the E-field are obtained, essential for the applications of the novel memory and logic devices. In this study, we also demonstrate the large magnetization changes in CoFe/Metglas/(011) PMN-PT heterostructures. The bilayered films also show excellent soft magnetic properties with high magnetostriction due to an extremely low coercive field ($H_c \approx 1.13$ Oe (Ref. 23) or 0.09 kA/m) and relatively high magnetostriction constant ($\lambda \approx 35$ ppm (Ref. 23)) for the

^{a)}Electronic mail: m.rainforth@sheffield.ac.uk

Metglas layer. The H_c of CoFe film on (001) PMN-PT substrate is reduced from ~ 4 kA/m to ~ 1 kA/m when the Metglas layer is introduced. Meanwhile, the λ is also improved from 35 ± 5 ppm to 60 ± 10 ppm. Such bilayered films with low H_c and high λ provide great opportunities to switch magnetization direction under a low energy level in the magnetoelectric (ME) heterostructures. In addition, a large lattice mismatch ($\sim 28.9\%$) between the CoFe ($a_{\text{CoFe}} = 2.858 \text{ \AA}$ (Ref. 24)) and the PMN-PT ($a_{\text{PMN-PT}} = 4.021 \text{ \AA}$ (Ref. 25)) may induce a weak tensile strain in the film layer. The introduction of the amorphous layer should eliminate the potential strain, which may be helpful to the magnetoelastic coupling.

EXPERIMENTS

Bilayered ferromagnetic films of CoFe/Metglas were directly deposited onto both (001) and (011)-oriented $[\text{Pb}(\text{Mg}_{1/3}\text{Nb}_{2/3})\text{O}_3]_{(1-x)}[\text{PbTiO}_3]_x$ (PMN-PT, $x \approx 0.28$) substrates without breaking the vacuum by RF sputtering in a Nordiko NM2000 RF deposition system. The targets used were polycrystalline $\text{Co}_{50}\text{Fe}_{50}$ alloy and amorphous METGLAS[®] 2605SC foil with the $\text{Fe}_{81}\text{B}_{13.5}\text{Si}_{3.5}\text{C}_2$ composition. The sputtering power, working pressure, and base pressure were 75 W, 5.0 ± 0.1 mTorr, and $1.2 \pm 0.2 \times 10^{-3}$ mTorr, respectively. The growth temperature was almost room temperature. The (001)-oriented PMN-PT (5 mm [100] \times 5 mm [010] \times 0.4 mm [001]) provided biaxial strains with in-plane piezoelectric coefficient of $d_{31} = -1000$ pC/N,²⁶ while the (011)-oriented PMN-PT (10 mm [01-1] \times 5 mm [100] \times 0.5 mm [011]) had the anisotropic strains with in-plane piezoelectric coefficients of $d_{31} = -1500 \sim -2000$ pC/N and $d_{32} = 500\text{--}700$ pC/N reported by the supplier. The substrates were polled at an E-field of 5 kV/cm for 10 min through the thickness before being used, which is to ensure the substrate has a converse piezoelectric effect, i.e., the E-field is able to induce a strain in the substrate. Magneto-optical Kerr effect (MOKE) measurements were used to investigate magnetic properties when a series of dc E-fields were applied to the substrates, as shown in the schematic in Fig. 1. The normalized remanent magnetization (M_r/M_s) and anisotropic field (H_k) were taken from the magnetic hysteresis loops. The H_k was taken at the $M/M_s = 1$. The effective saturation magnetostriction constants (λ) were measured using a technique²⁷ based on the Villari effect. Cross-sectional transmission electron microscopy (TEM) specimens were prepared by Focused Ion Beam (FIB) in FEI Quanta 200 3D and observed on both FEI Tecnai T20 and Jeol 2010F operating at 200 kV.

RESULTS AND DISCUSSION

To understand the microstructure of the magnetic films and interfaces in the heterostructure, cross-sectional TEM was undertaken. Fig. 2(a) gives a bright field TEM image of the cross-section, while (b) and (c) give high-resolution TEM (HRTEM) images and selected area electron diffraction (SAED) pattern (d). The interface between the amorphous Metglas film and the PMN-PT (Fig. 2(b)) is well-defined and smooth, while that between the Metglas film and the CoFe film (Fig. 2(c)) is much rougher. The CoFe

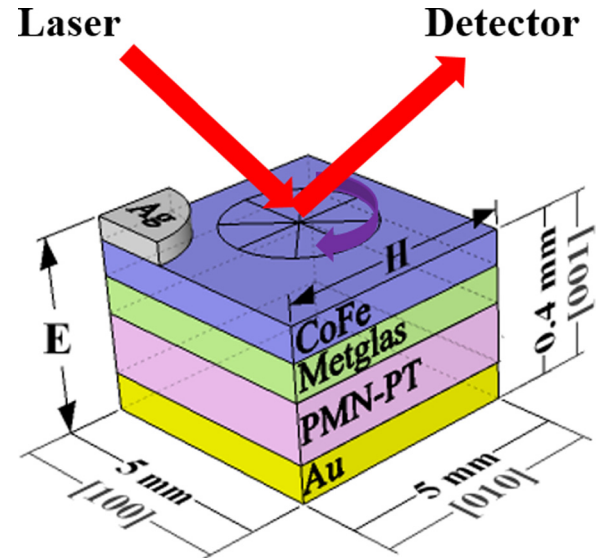


FIG. 1. A schematic (not to scale) of 65 nm CoFe/24 nm metglas/400 μm (001) PMN-PT heterostructure. Magnetic properties were measured by MOKE system. Magnetic field (H) was fixed and applied in plane, while the E was applied through the thickness. The sample was measured with rotating within 360° .

film still shows a polycrystalline structure with an out-of-plane [110] texture even on the amorphous layer, as shown in Fig. 2(d).

Fig. 3 shows a strong ME coupling in all samples of both (001)-oriented and (011)-oriented PMN-PT substrates. For the [100] crystallographic direction (Figs. 3(b), 3(d), and 3(f)), when the applied E-field increases, the M_r/M_s reduces and H_k increases. In contrast, M_r/M_s increases and H_k reduces along either direction [010] (Fig. 3(a)) or [01-1] (Fig. 3(e)) due to a compressive strain along [100] and positive magnetostriction constant (λ). As shown in Fig. 3(c), the λ of the bilayered magnetic films increases from 35 ± 5 ppm to 60 ± 10 ppm when the Metglas thickness is greater than 6 nm, which may be attributed to a negative interface effect²⁸ removed by Metglas underlayer between CoFe and substrate. In addition, the λ of the bilayered magnetic films (65 nm CoFe/24 nm Metglas and 30 nm CoFe/12 nm Metglas) is similar at around 60 ppm. However, the thinner bilayered films show stronger ME coupling than the thicker bilayered films, as shown in Figs. 3(d)–3(f), which is consistent with the previous investigation²⁹ on the effect of magnetic layer thickness on ME coupling. Reducing the magnetic layer thickness can cause the reduction in the strain relaxation and thus increase the ME coupling. In the 30 nm CoFe/12 nm Metglas/(011) PMN-PT sample, a maximum $\Delta M_r/M_s$ is measured along the [100] direction of 80% at the applied E-field of 10 kV/cm, while along the [01-1] direction $\Delta M_r/M_s$ is 60% at the applied E-field of only 5 kV/cm, corresponding to a giant ME coupling constant³⁰ $\alpha = \mu_0 \Delta M_r/E = 2.9 \times 10^{-6}$ s/m, which is much larger than 1.6×10^{-7} s/m,³¹ 4.55×10^{-7} s/m (Ref. 7), and 8×10^{-7} s/m (Ref. 29) reported in monolayer magnetic film systems. In addition, it is noted that the H_c is increased significantly by a factor of three when the E-field of 10 kV/cm was applied to the 65 nm CoFe/24 nm Metglas/(011) PMN-PT sample. For (001)-oriented PMN-PT's

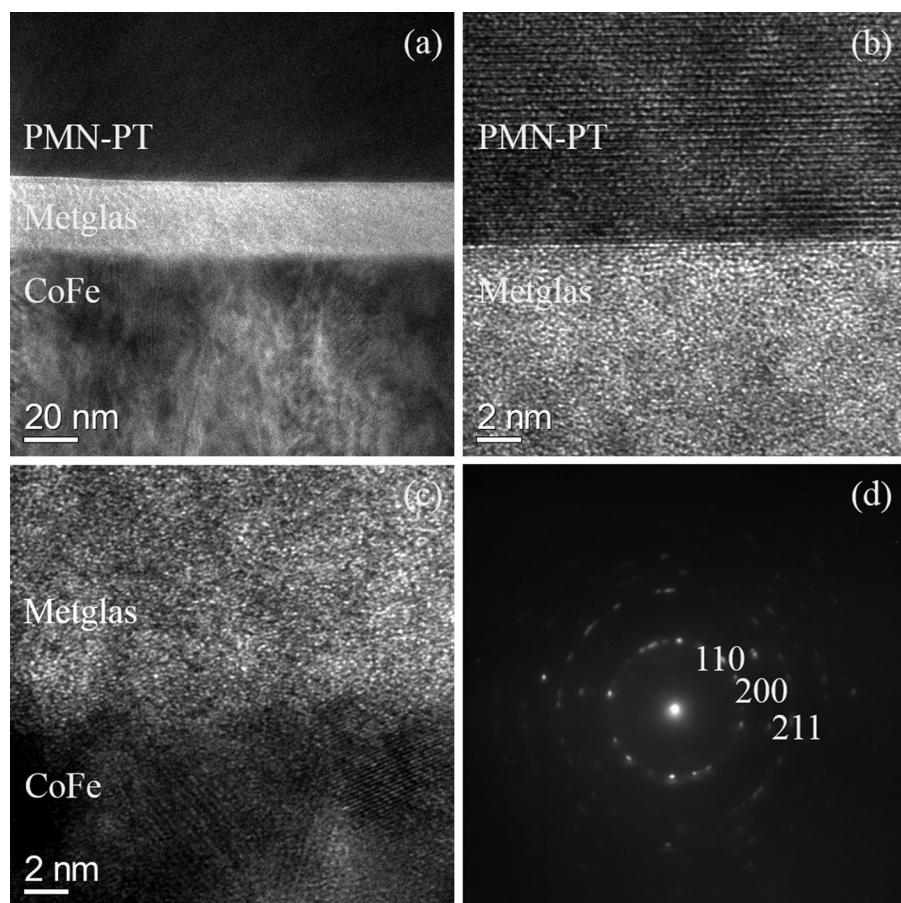


FIG. 2. Cross-sectional bright field TEM image (a) and HRTEM images (b) and (c) of the CoFe/Metglas/PMN-PT heterostructure. The SAED pattern (d) of CoFe film.

heterostructure, more detailed magnetization change induced by the E-field is discussed as follows in Figs. 4–7.

Fig. 4 shows an angular dependence of the M_r/M_s and H_k in the 65 nm CoFe/24 nm Metglas/(001) PMN-PT sample. The 0° corresponds to the [010] direction of PMN-PT substrate. The magnetic anisotropy in both M_r/M_s and H_k is weak without the applied E-field. With the increasing E-field to +3 kV/cm and +6 kV/cm, the anisotropy is steadily strengthened. At the maximum E-field of +6 kV/cm, the bilayered magnetic films show a uniaxial anisotropy. The magnetization becomes easy along [010], while it becomes hard along [100] due to the E-field inducing positive effective H_k along [100] and negative effective H_k along [010]. The results are consistent with the previous reports in CoPd/(001) PMN-PT system²⁹ and NiFe₂O₄/(001) PMN-PT system.⁵ Similarly, for Fe₃O₄/PZT ($d_{31} = d_{32} < 0$) system,⁶ a large change M_r of 44% was also observed when external magnetic field was along in-plane direction. However, the reason why the in-plane biaxial strain can induce the large in-plane anisotropy change was not explained in these reports. Here, we think the magnitude of the compressive strains along [100] and [010] should be different, which leads a total compressive strain along a sole direction. Therefore, the uniaxial anisotropy is induced by the biaxial compressed strains²⁵ with an estimated total compressive strain ($\Delta \epsilon = -0.07\%$ (Refs. 5 and 32)) along [100] at applied E-field of 6 kV/cm.

Figs. 5(a) and 5(b) show the electrical dependence of the M_r/M_s and H_k along [010] direction with two opposite

sweeping fields from +6 kV/cm to -6 kV/cm and from -6 kV/cm to +6 kV/cm, respectively. The arrows indicate the direction of the E-field sweeping. The changes in M_r/M_s and H_k show typical “butterfly” curves dependence on the E-field, which resembles curves of piezoelectric strains against the E-field change,²² suggesting that piezoelectric strains induce strong ME coupling through the inverse magnetostrictive effect. The sharp valleys and peaks of the curves in Fig. 5 are caused by a large nonlinear strain jump below the ferroelectric coercive field ($E_c \approx 2$ kV/cm), which is attributed to the reorientation of non-180° ferroelectric polarization.²¹ The comparable change ratios of M_r/M_s , H_k , and H_c to the initial values are 71%, 76%, and 69%, respectively. In addition, a non-volatile magnetization change is demonstrated, as shown in Fig. 5(a). Two distinct bistable magnetization states “1” and “2” are created by the different direction of the sweeping E-field and also can be reversibly switched by the E-field. Therefore, these can be directly read out electrically by magnetotransport measurements, which demonstrate the potential for the MERAM memory cell application. A short voltage impulse can change the magnetization without continuous E-field needed and an opposite voltage signal can return the magnetization to the other state. This may be typically utilized to develop fast, low-power and high-density information storage device by E-field instead of the H-field generated by bulky and energy-consuming electromagnets.

Figs. 6(a) and 6(b) show the electrical dependence of M_r/M_s along [100] with the different E-field sweeping

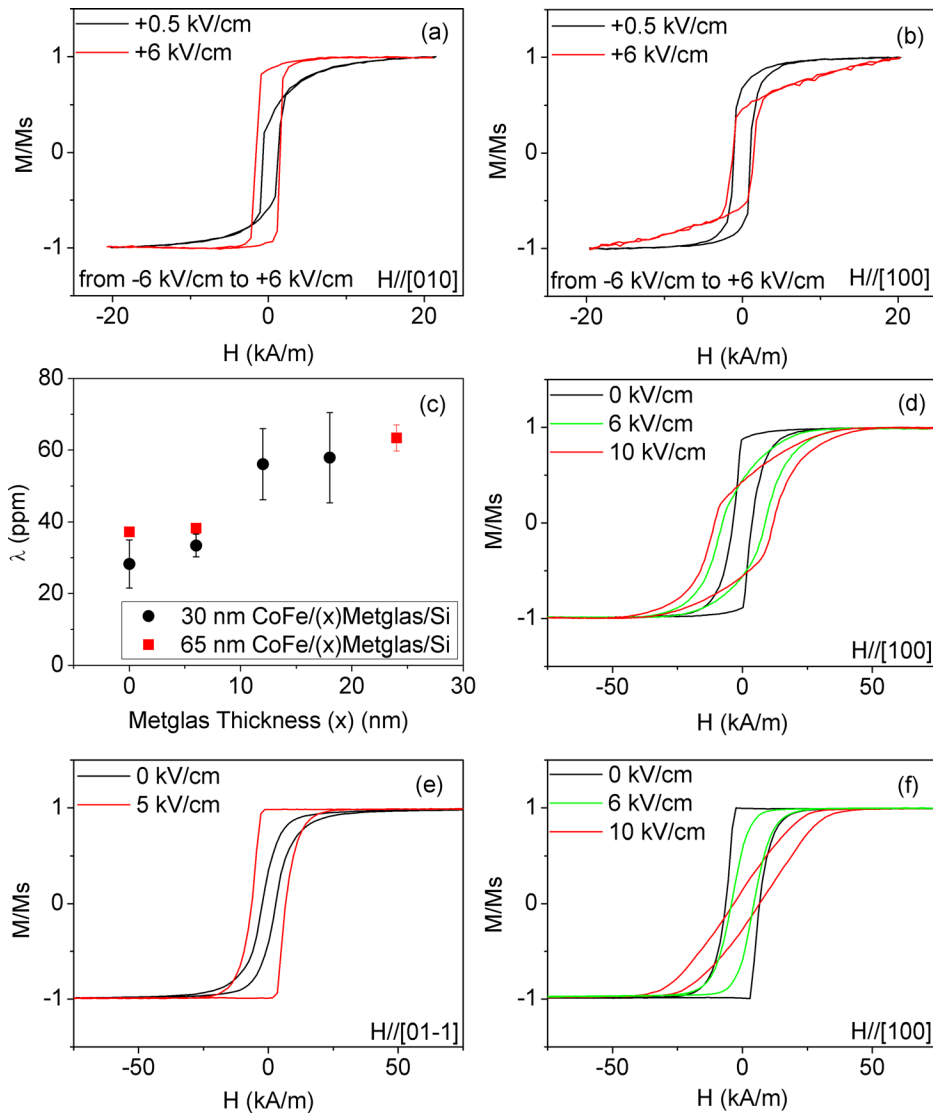


FIG. 3. Electric-field dependence of magnetic hysteresis loops in 65 nm CoFe/24 nm Metglas/(001) PMN-PT heterostructure (a) and (b), in 65 nm CoFe/24 nm Metglas/(011) PMN-PT heterostructure (d) and in 30 nm CoFe/12 nm Metglas/(011) PMN-PT heterostructure (e) and (f). The variation of effective saturation magnetostriction constants (λ) with Metglas thickness (x) (c).

directions. The arrows indicate the direction of the E-field sweeping. The results along [010] are also plotted together for comparison. The opened symbols (square and circle) represent the as-grown M_r/M_s along [010] and [100],

respectively. The as-grown M_r/M_s along [100] and [010] are taken from magnetic hysteresis loops measured before any applied E-field. It is clear to see that the results between the two directions of [100] and [010] show an opposite variation

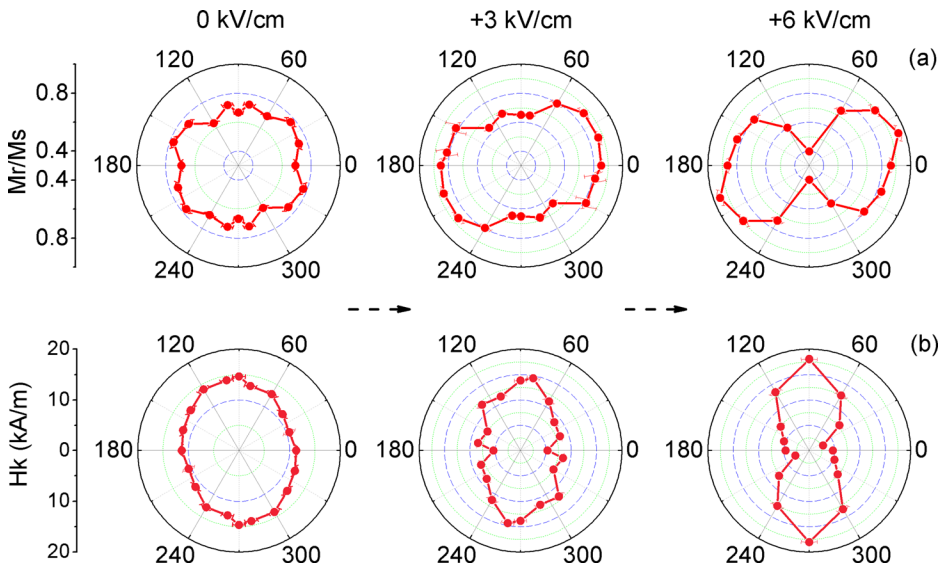


FIG. 4. The angular dependence of the M_r/M_s (a) and H_k (b) with the increasing applied E: 0 kV/cm, +3 kV/cm, and +6 kV/cm in 65 nm CoFe/24 nm Metglas/(001) PMN-PT heterostructure.

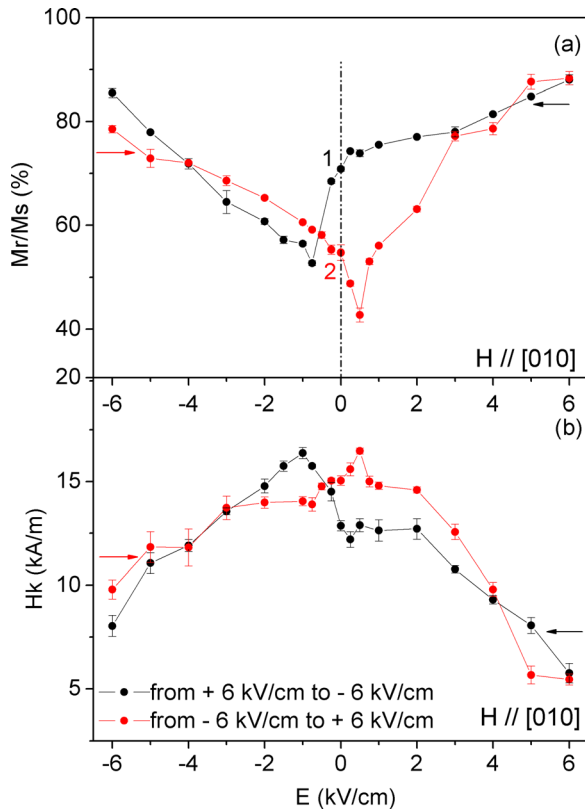


FIG. 5. Electrical dependence of the M_r/M_s (a) and H_k (b) along [010] with different E sweeping directions in 65 nm CoFe/24 nm Metglas/(001) PMN-PT heterostructure. The arrows indicate the direction of the E-field sweeping.

tendency, which is consistent with previous reports.^{5,29,32} The positions of valleys and peaks along [100] and [010] are the same, with +0.5 kV/cm in Fig. 6(a) and -0.75 kV/cm in Fig. 6(b). In addition, it is noted that the value of M_r/M_s does not return to the as-grown value after removing the E-field, but remains a permanent change in magnetization state and anisotropy, which suggests that the E-field creates two stable remaining strain states which are transferred to the bilayered magnetic films due to the elastic coupling.

A hysteresis loop of MR measured along [100] as a function of the applied E-field is demonstrated in Fig. 7. When the E-field changes from -2 kV/cm to 1.75 kV/cm or from -0.75 kV/cm to -1.75 kV/cm, the magnetization is along [100], while when the E-field changes from 6 kV/cm to -0.75 kV/cm or from 1.75 kV/cm to 6 kV/cm, the magnetization is along [010], as shown in Fig. 7. Based on the anisotropic magnetoresistance effect (AMR), when the magnetization is parallel to a test current, a low MR is measured, while when the magnetization is perpendicular to the test current, a high MR is measured. On the other hand, when a non-magnetic metal layer is introduced between the bilayered magnetic films, based on the GMR effect, the low MR is measured when magnetization in the free magnetic layer is parallel to that in the pinned magnetic layer, while the high MR is measured, when magnetization in free magnetic layer is anti-parallel to that in pinned magnetic layer. The parallel and anti-parallel magnetization between the free layer and the pinned layer is easy to achieve by

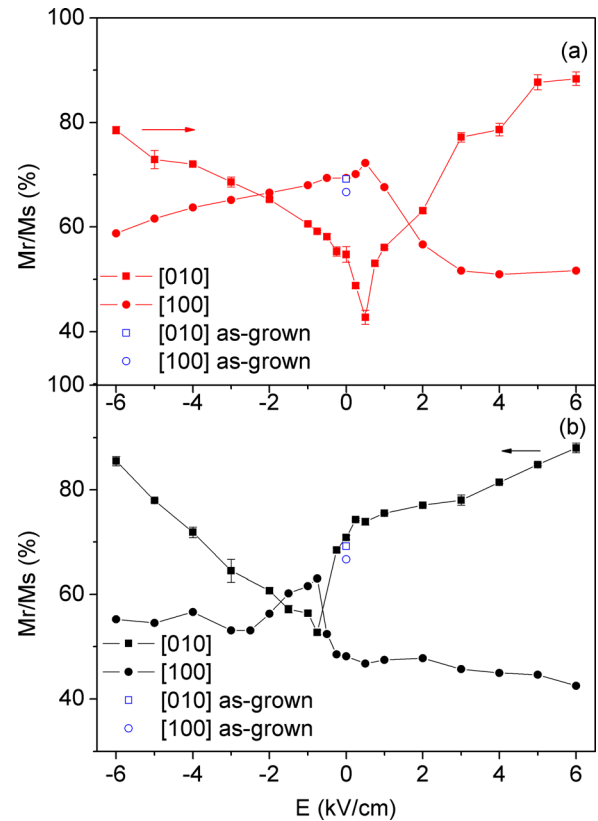


FIG. 6. Electrical dependence of the M_r/M_s along [100] with different E-field sweeping directions in 65 nm CoFe/24 nm Metglas/(001) PMN-PT heterostructure. Those along [010] also were plotted together for the comparison. The arrows indicate the direction of the E-field sweeping: (a) from -6 kV/cm to +6 kV/cm and (b) from +6 kV/cm to -6 kV/cm.

choosing ferromagnetic films with obvious different λ . In this study, we only focus on E-field controlled bilayered magnetic films.

In summary, strong ME coupling was observed in all these heterostructures based strain mediated mechanism. The giant ME coupling constant $\alpha = 2.9 \times 10^{-6}$ s/m was demonstrated in 30 nm CoFe/12 nm Metglas/(011) PMN-PT heterostructure due to the improved λ and reduced magnetic layer thickness. The non-volatile magnetization change was shown

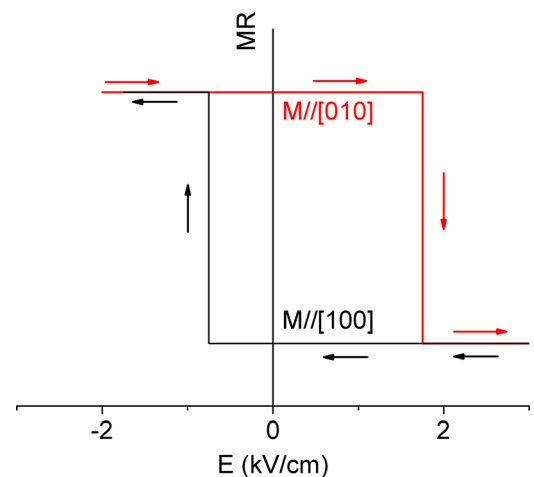


FIG. 7. A hysteresis loop of MR as a function of the applied E with magnetization change.

in CoFe/Metglas/(001) PMN-PT heterostructure. Two new created bistable magnetization states could be reversibly switched by an E-field, while the as-grown state was permanently altered. Based on GMR or AMR, the MERAM memory cell was proposed for the fast, low-power, and high-density information storage.

ACKNOWLEDGMENTS

This work was financially supported by a University of Sheffield Prize Scholarship.

- ¹C. Israel, N. D. Mathur, and J. F. Scott, *Nature Mater.* **7**, 93 (2008).
- ²C. Chappert, A. Fert, and F. N. Van Dau, *Nature Mater.* **6**, 813 (2007).
- ³D. Barrionuevo, N. Ortega, A. Kumar, R. Chatterjee, J. F. Scott, and R. S. Katiyar, *J. Appl. Phys.* **114**, 234103 (2013).
- ⁴M. Bibes and A. Barthélemy, *Nature Mater.* **7**, 425 (2008).
- ⁵J. H. Park, Y. K. Jeong, S. Ryu, J. Y. Son, and H. M. Jang, *Appl. Phys. Lett.* **96**, 192504 (2010).
- ⁶M. Liu, O. Obi, J. Lou, Y. J. Chen, Z. H. Cai, S. Stoute, M. Espanol, M. Lew, X. Situ, K. S. Ziemer, V. G. Harris, and N. X. Sun, *Adv. Funct. Mater.* **19**, 1826 (2009).
- ⁷Y. Zhang, Z. G. Wang, Y. J. Wang, C. T. Luo, J. F. Li, and D. Viehland, *J. Appl. Phys.* **115**, 084101 (2014).
- ⁸M. Liu, Z. Y. Zhou, T. X. Nan, B. M. Howe, G. J. Brown, and N. X. Sun, *Adv. Mater.* **25**, 1435 (2013).
- ⁹J. Wang, J. Hu, H. Wang, H. Jiang, Z. Wu, J. Ma, X. Wang, Y. Lin, and C. W. Nan, *J. Appl. Phys.* **107**, 083901 (2010).
- ¹⁰J. J. Yang, Y. G. Zhao, H. F. Tian, L. B. Luo, H. Y. Zhang, Y. J. He, and H. S. Luo, *Appl. Phys. Lett.* **94**, 212504 (2009).
- ¹¹Y. Chen, J. Gao, T. Fitchorov, Z. Cai, K. S. Ziemer, C. Vittoria, and V. G. Harris, *Appl. Phys. Lett.* **94**, 082504 (2009).
- ¹²J. W. Lee, S. C. Shin, and S. K. Kim, *Appl. Phys. Lett.* **82**, 2458 (2003).
- ¹³M. Liu, O. Obi, Z. Cai, J. Lou, G. Yang, K. S. Ziemer, and N. X. Sun, *J. Appl. Phys.* **107**, 073916 (2010).
- ¹⁴W. Eerenstein, N. D. Mathur, and J. F. Scott, *Nature* **442**, 759 (2006).
- ¹⁵N. Ortega, A. Kumar, R. S. Katiyar, and J. F. Scott, *Appl. Phys. Lett.* **91**, 102902 (2007).
- ¹⁶W. Eerenstein, F. D. Morrison, J. Dho, M. G. Blamire, J. F. Scott, and N. D. Mathur, *Science* **307**, 1203a (2005).
- ¹⁷N. Ortega, A. Kumar, J. F. Scott, D. B. Chrisey, M. Tomazawa, S. Kumari, D. G. B. Diestra, and R. S. Katiyar, *J. Phys.: Condens. Matter* **24**, 445901 (2012).
- ¹⁸M. Liu, S. D. Li, O. Obi, J. Lou, S. Rand, and N. X. Sun, *Appl. Phys. Lett.* **98**, 222509 (2011).
- ¹⁹A. Brandlmaier, S. Geprägs, G. Woltersdorf, R. Gross, and S. T. B. Goennenwein, *J. Appl. Phys.* **110**, 043913 (2011).
- ²⁰Z. Li, J. Wang, Y. Lin, and C. W. Nan, *Appl. Phys. Lett.* **96**, 162505 (2010).
- ²¹T. Wu, A. Bur, P. Zhao, K. P. Mohanchandra, K. Wong, K. L. Wang, C. S. Lynch, and G. P. Carman, *Appl. Phys. Lett.* **98**, 012504 (2011).
- ²²S. W. Yang, R. C. Peng, T. Jiang, Y. K. Liu, L. Feng, J. J. Wang, L. Q. Chen, X. G. Li, and C. W. Nan, *Adv. Mater.* **26**, 7091 (2014).
- ²³Y. Chen, T. Fitchorov, Z. Cai, K. S. Ziemer, C. Vittoria, and V. G. Harris, *J. Phys. D: Appl. Phys.* **43**, 155001 (2010).
- ²⁴V. A. Vas'ko, J. O. Rantschler, and M. T. Kief, *IEEE Trans. Magn.* **40**, 2335 (2004).
- ²⁵S. Das, A. Herklotz, E. Pippel, E. J. Guo, D. Rata, and K. Dörr, *Phys. Rev. B* **91**, 134405 (2015).
- ²⁶P. Han, W. Yan, J. Tian, X. Huang, and H. Pan, *Appl. Phys. Lett.* **86**, 052902 (2005).
- ²⁷A. Javed, N. A. Morley, and M. R. J. Gibbs, *J. Magn. Magn. Mater.* **321**, 2877 (2009).
- ²⁸S. Kotapati, A. Javed, N. Reeves-Mclaren, M. R. J. Gibbs, and N. A. Morley, *J. Magn. Magn. Mater.* **331**, 67 (2013).
- ²⁹J. H. Kim, K. S. Ryu, J. W. Jeong, and S. C. Shin, *Appl. Phys. Lett.* **97**, 252508 (2010).
- ³⁰W. Eerenstein, M. Wiora, J. L. Prieto, J. F. Scott, and N. D. Mathur, *Nature Mater.* **6**, 348 (2007).
- ³¹Y. Chen, T. Fitchorov, C. Vittoria, and V. G. Harris, *Appl. Phys. Lett.* **97**, 052502 (2010).
- ³²C. Thiele, K. Dörr, O. Bilani, J. Rödel, and L. Schultz, *Phys. Rev. B* **75**, 054408 (2007).